YAO-3950



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Yoshihisa Nagano et al.

: Art Unit: 2815

Serial No.:

09/103,873

: Examiner: J. Diaz

Filed:

June 24, 1998

For: SEMICONDUCTOR DEVICE AND

METHOD FOR FABRICATING THE SAME

AMENDMENT AND REQUEST FOR EXTENSION OF TIME

Assistant Commissioner for Patents Washington, DC 20231

SIR:

Responsive to the Official Action dated July 5, 2000, please amend the above-identified application as follows:

IN THE DRAWINGS:

Subject to approval by the Examiner in charge of the aboveidentified application, amend Figures 10A, 10B, 10C, 10D and 10E as indicated in red on the marked-up copies of these Figures.

REMARKS

Claims 1-10 stand rejected under 35 U.S.C. § 103(a) as being unpatentable over Applicant's specification in view of Yoshizumi et al.(U.S. patent # 5,444,012), and further in view of Matsuura et al. (U.S. Patent # 5,132,774). However, the Office Action did not recite a clear rejection of the claims nor a clear basis for rejecting the claims. Therefore, an interview was conducted on July, 14, 2000, so that Applicants could receive a better explanation and understanding of the rejections recited in the Office Action.

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